

Editorial Board

Editor-in-Chief

ROBERT C. POST

Book Review Editor

ARTHUR P. MOLELLA
National Museum of
American History

Exhibit Review Editor

LARRY D. LANKTON
Michigan Technological
University

Chief Advisory Editor

BROOKE HINDLE
National Museum of
American History

Editorial Committee

EDWIN T. LAYTON, JR.
Chairman
University of Minnesota

Copy Editor

JOAN E. MENTZER

Advisory Editors

HUGH G. J. AITKEN
AUGUST W. GIEBELHAUS
BERT S. HALL
PAUL HANLE
JOHN R. HARRIS
ROBIN HIGHAM
DAVID A. HOUNSHELL
ALEX KELLER
JOHN A. KOUWENHOVEN
GARY B. KULIK
A. RAHMAN

WAYNE RASMUSSEN
MARGARET W. ROSSITER
DENISE SCHMANDT-BESSERAT
NATHAN SIVIN
MERRITT ROE SMITH
JOANN VANEK
JOHN H. WHITE, JR.

Amherst College
Georgia Institute of Technology
University of Toronto
National Air and Space Museum
University of Birmingham
Kansas State University
University of Delaware
University of Leicester
Barnard College
National Museum of American History
Council of Scientific and Industrial
Research (India)
U.S. Department of Agriculture
National Science Foundation
University of Texas—Austin
University of Pennsylvania
Massachusetts Institute of Technology
United Nations Secretariat
National Museum of American History

Technology and Culture (ISSN 0040-165X) is published four times a year, January, April, July, and October, by The University of Chicago Press. Subscriptions: institutions, 1 year \$45.00, 2 years \$81.00; individuals, 1 year \$26.00, 2 years \$46.80. Student rate (U.S.A.): 1 year \$18.00 (letter from professor must accompany subscription). Emeritus, 1 year \$22.00. Add \$3.00/year postage for subscriptions mailed outside the U.S.A. and its possessions. Single copies: institutions \$11.25, individuals \$6.50. Back issues are available from 1977 (vol. 18). Subscriptions include membership in the Society for the History of Technology. Checks should be made payable to The University of Chicago Press, Journals Division, P.O. Box 37005, Chicago, Illinois 60637; all business correspondence, including changes of address (old as well as new address), should be sent to that address.

Volumes 1-17 available from Kraus Reprints, Route 100, Millwood, New York 10546. All volumes are available in microfilm from University Microfilms, 300 North Zeeb Road, Ann Arbor, Michigan 48106; in microfiche from KTO Microform, Route 100, Millwood, New York 10546.

Editorial correspondence, manuscripts, and books for review should be sent to Dr. Robert C. Post, National Museum of American History, Smithsonian Institution, Washington, D.C. 20560.

Editorial office sponsored by National Museum of American History, Roger G. Kennedy, director.

Published by The University of Chicago Press, Chicago, Illinois 60637; The University of Chicago Press Ltd., London W.C. 1. Second-class postage for *Technology and Culture* paid at Chicago.

© 1984 by the Society for the History of Technology. All rights reserved.